

## LIST OF ART CITED BY APPLICANT

(Use several sheets if necessary)

Atty Docket No. A01215A	Serial No.
Applicant Anne Mae Gaffney, et al.	
Filing Date Herewith	Group

## U.S. Patent Documents

EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS/SUBCLASS	FILING DATE IF APPROPRIATE
ks	AA	5,281,745	1/25/1994	Ushikubo, et al.	—	
	AB	5,380,933	1/10/1995	Ushikubo, et al.	—	
	AC	6,043,185	3/28/2000	Cirjak, et al.	—	
	AD	5,472,925	12/05/1995	Ushikubo, et al.	—	
ks	AE	6,080,882	6/27/2000	Midorikawa, et al.	—	
	AF					
	AG					
	AH					
	AI					
	AJ					

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/SUBCLASS	TRANSLATION YES/NO
ks	AK	0 630 879 B1	12/28/1994	Europe	—	
	AL	WO 00/09260	2/24/2000	WIPO		
1	AM	WO 00/29106	5/25/2000	WIPO		
	AN	7-53448	2/28/1995	Japan		Yes
	AO	2000-37623	2/8/2000	Japan		Yes
ks	AP	0 281 280	9/07/88	Europe	—	

## OTHER ART (Including Author, Title, Date, Pertinent Patents, etc.)

ks	AR	Translation of Japanese Laid-Open Patent Application Publication No. 6-228073(8/16/94).
ks	AS	of Japanese Laid-Open Patent Application Publication No. 2000-254496(9/19/2000).
	AT	

Examiner Leanneal Saad Date Considered 03/01/05

\*EXAMINER: Initial reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.